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ATM-515 (7486)

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Patent Application

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Docket No.:

ATMI-515 (7486)

Applicant:

XU, Chongying, et al.

Examiner:

Art Group:

Virginia MANOHARAN

Application No.: 10/015,326

1764

Date Filed:

December 13, 2001

Confirm. No.:

2946

Title:

METHOD FOR REMOVAL OF IMPURITIES IN CYCLIC SILOXANES USEFUL AS PRECURSORS FOR LOW **DIELECTRIC CONSTANT** 

THIN FILMS

Customer No.:

25559

FACSIMILE TRANSMISSION CERTIFICATE ATTN: Examiner Virginia MANOHARAN

Fax No.: (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop AF, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on July 25, 2005, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300

July 25, 2005

Date

**RESPONSE TO MAY 25, 2005 OFFICE ACTION** IN UNITED STATES PATENT APPLICATION NO. 10/015,326

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the May 25, 2005 Office Action, please amend the application as follows:

Entered West 11/10/05